

F-7041



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2823

M/B (N.E)  
J. Steptoe  
9-18-03

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Kiyohiko TAKAGI, et al.  
Serial No. : 09/892,023  
Filed : June 26, 2001  
For : DRYING ETCHING METHOD  
Group Art Unit : 2823  
Examiner : William D. Coleman

**Certificate of Mailing Under 37 CFR 1.8**

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on August 26, 2003.

Jacqueline M. Steady  
(Name)

Jacqueline M. Steady  
(Signature)

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

MAILSTOP AF  
Commissioner for Patents  
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

In response to the final Office Action of January 21, 2003 entry of the present amendment to place the application into condition for allowance or remove issues from appeal, if required, is respectfully requested. Please amend the above-identified patent application as follows: